



Docket No. 740756-2297

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Application No. 09/837,558

Filed: April 19, 2001

For: SEMICONDUCTOR DEVICE AND  
MANUFACTURING METHOD  
THEREOF

)

) Group Art Unit: 2814

) Examiner: Nathan W. Ha

) Confirmation No. 7532

) Date: November 17, 2004

CERTIFICATE OF MAILING OR TRANSMISSION  
[37 CFR 1.8(a)]

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Signature: \_\_\_\_\_

Name: \_\_\_\_\_

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed August 15, 2003, please consider the amendments and remarks in connection with the above-identified application as follows.